

## RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 1763

**PATENT** 

Customer No. 22,852 Attorney Docket No. 07553.0017

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Mitsuru ISHIKAWA et al.	) Group Art Unit: 1763
Application No.: 09/696,232	) Examiner: Olsen, Allan
Filed: October 26, 2000	) )
For: ETCHING METHOD	) )

Mail Stop AF
Commissioner for Patents

P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **AMENDMENT AFTER FINAL**

In reply to the Final Office Action mailed September 16, 2004, the period for response having been extended to March 16, 2005 by a Petition for Extension of Time - Three Months - and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Specification are included on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims beginning on page 3 of this paper.

Remarks follow the amendment section of this paper.